

Notice of References Cited

Application/Control No.

09/884,467

Applicant(s)/Patent Under
Reexamination
BEDELL ET AL.

Examiner

Luke S. Wassum

Art Unit

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0046204 A1	04-2002	Hayes, Scott R.	707/1
	B	US-			
	C	US-			
	D	US-			
	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	IBM "OS/390 Resource Measurement Facility Report Analysis", document SC28-1950-05, 6 th Edition, September 2000, pp. 1-1 through 1-7, 2-240 through 2-262, and 5-1 through 5-52.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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